

Docket No.: 60188-156

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Masahiro FUKUI, et al.

Serial No.:

Group Art Unit:

Filed: March 01, 2002

Examiner:

For: WIRING METHOD IN LAYOUT DESIGN OF SEMICONDUCTOR INTEGRATED
CIRCUIT, SEMICONDUCTOR INTEGRATED CIRCUIT AND FUNCTIONAL
MACRO

J1046 U.S. PTO
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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Handwritten signature of Michael E. Fogarty
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